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U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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/SMH/	2002-219591 A	Aug. 6, 2002	JP			Abstract	
/SMH/	1 338 371 A1	Aug. 27, 2003	EP				
/SMH/	2001-340979 A	Dec. 11, 2001	JP			Abstract	
/SMH/	2000-084688 A	Mar. 28, 2000	JP			Abstract	
/SMH/	11-104873 A	Apr. 20, 1999	JP			Abstract	
/SMH/	09-019784 A	Jan. 21, 1997	JP			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

- /SMH/ Kiyotaka MIURA et al., "Formation of Photo-induced Structures in Glasses with Femtosecond Laser," Dai 42 Kai Proceedings of Laser Materials Processing Conference, 1997, pp. 105-111.
- /SMH/ Ken-ichi HAYASHI, "Inner Glass Marking by Harmonics of Solid State Laser," Dai 45 Kai Proceedings of Laser Materials Processing Conference, 1998, pp. 23-28.
- /SMH/ Tomokazu SANO et al., "Ultrashort Pulse Laser Microprocessing of Silicon," Short Pulse and Short Wavelength Laser Precision Microprocessing of Electric Materials (first report), 2000, pp. 72-73.
- /SMH/ Shuji TAKAOKA, "Principle and Characteristics of Stealth Dicing Technology Optimal for Dicing of Ultrathin Semiconductor Wafer," Denshi Zairyo, September 1, 2002, pp. 17-21.

Examiner /Samuel M. Heinrich/ (10/15/2009)	Date Considered
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